

Sayleap

List of Publications by Year in descending order

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6

papers

110

citations

1478505

6

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1872680

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g-index

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docs citations

6

times ranked

107

citing authors

#	ARTICLE	IF	CITATIONS
1	Probe-induced surface defects: Origin of leakage current in halide vapor-phase epitaxial (001) $\hat{I}^2\text{-Ga}_2\text{O}_3$ Schottky barrier diodes. <i>Applied Physics Letters</i> , 2022, 120, .	3.3	10
2	High crystal quality of vertical Bridgman and edge-defined film-fed growth $\hat{I}^2\text{-Ga}_{2\langle\text{sub}\rangle\text{O}_{\langle\text{sub}\rangle 3\langle/\text{sub}\rangle}}$ bulk crystals investigated using high-resolution X-ray diffraction and synchrotron X-ray topography. <i>Japanese Journal of Applied Physics</i> , 2022, 61, 055501.	1.5	8
3	Line-shaped defects: Origin of leakage current in halide vapor-phase epitaxial (001) $\langle b \rangle \langle i \rangle \hat{I}^2 \langle /i \rangle \langle /b \rangle\text{-Ga}_{2\langle\text{sub}\rangle\text{O}_{\langle\text{sub}\rangle 3\langle/\text{sub}\rangle}}$ Schottky barrier diodes. <i>Applied Physics Letters</i> , 2022, 120, 122107.	3.3	8
4	Polycrystalline defectsâ€”origin of leakage currentâ€”in halide vapor phase epitaxial (001) $\hat{I}^2\text{-Ga}_{2\langle\text{sub}\rangle\text{O}_{\langle\text{sub}\rangle 3\langle/\text{sub}\rangle}}$ Schottky barrier diodes identified via ultrahigh sensitive emission microscopy and synchrotron X-ray topography. <i>Applied Physics Express</i> , 2021, 14, 036502.	2.4	21
5	Stacking faults: Origin of leakage current in halide vapor phase epitaxial (001) $\langle b \rangle \langle i \rangle \hat{I}^2 \langle /i \rangle \langle /b \rangle\text{-Ga}_2\text{O}_3$ Schottky barrier diodes. <i>Applied Physics Letters</i> , 2021, 118, .	3.3	29
6	Origin of reverse leakage current path in edge-defined film-fed growth (001) $\langle b \rangle \langle i \rangle \hat{I}^2 \langle /i \rangle \langle /b \rangle\text{-Ga}_2\text{O}_3$ Schottky barrier diodes observed by high-sensitive emission microscopy. <i>Applied Physics Letters</i> , 2020, 117, .	3.3	34